

Dkt. 71745 CCD



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Todd F. BISCHOFF et al.

Serial No. : 10/735,057 Group Art Unit 1732

Filed : December 11, 2003 Examiner M. J. Daniels

For : METHOD FOR SUPPRESSING REACTION OF
MOLTEN METALS WITH REFRACTORY MATERIALS

REPLY TO FINAL OFFICE ACTION

1185 Avenue of the Americas
New York, N.Y. 10036
June 28, 2006

Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

S I R:

In response to the final Office Action dated November 30, 2005, applicants respectfully request reconsideration and further examination of the above-identified application for the reasons set forth below.¹

Attention is respectfully directed to the attached copy of a Declaration under 37 C.F.R. §1.132 executed June 22, 2006, by Robert B. Wagstaff, one of the applicants herein.

¹A Notice of Appeal was filed May 8, 2006, and a Request for Continued Examination is being submitted concurrently herewith.